

Electronic Acknowledgement Receipt

EFS ID:	1181963
Application Number:	10721932
Confirmation Number:	8320
Title of Invention:	Method for etching a substrate and a device formed using the method
First Named Inventor:	K.R. Udayakumar
Customer Number:	23494
Filer:	Greg H. Parker
Filer Authorized By:	
Attorney Docket Number:	TI 35507
Receipt Date:	31-AUG-2006
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Application Type:	Utility
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Appeal Brief Filed	Appeal_Brief.pdf	865605	no	20

Warnings:	
Information:	
Total Files Size (in bytes):	865605
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<u>New Applications Under 35 U.S.C. 111</u> If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.	
<u>National Stage of an International Application under 35 U.S.C. 371</u> If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.	